

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S21 4	2945	((414/626,286,280,281,786,661,752,225,626,627) or (212/312,327)).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/11/05 19:37
S21 5	0	S214 rail adj4 cassette (raise or lift)	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/05 18:34
S21 6	33	S214 (rail or frame or track) (wafer or semiconductor) (raise or lift)	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/05 18:34
S21 8	15	S214 (rail or frame or track or path) (wafer or semiconductor) (raise or lift) conveyor	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/05 19:38
S21 9	7	S214 (rail or frame or track or path) (wafer or semiconductor) (raise or lift) conveyor robot	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/05 18:36
S22 0	2	S214 (rail or frame or track or path) adj4 robot (wafer or semiconductor) (raise or lift) conveyor robot	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/05 18:36
S22 4	0	(wafer or semiconductor) plus ceiling conveyor system	EPO; JPO	AND	ON	2004/11/05 18:53
S22 5	0	plus ceiling conveyor system	EPO; JPO	AND	ON	2004/11/05 18:54
S22 6	471	plus ceiling conveyor system	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/05 18:54
S22 7	35	plus ceiling conveyor system (wafer or semiconductor)	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/05 18:54
S22 8	1	"plus ceiling" conveyor system (wafer or semiconductor)	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/05 18:54
S22 9	6	("5955857").URPN.	USPAT	AND	ON	2004/11/05 18:54
S23 0	3738	((414/222.01,217.1,222.13,626,286,280,281,786,661,752,225,626,627,940) or (212/312,327)).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/11/05 19:38
S23 1	68	S230 (rail or frame or track or path) (wafer or semiconductor) (raise or lift) conveyor	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/06 17:23
S23 7	375	(elevate or lift or raise) adj3 (cassette or wafer or semiconductor)	JPO	AND	ON	2004/11/06 17:20
S23 8	0	(elevate or lift or raise) adj3 (cassette or wafer or semiconductor) timing belt	JPO	AND	ON	2004/11/06 17:20

S23 9	21	(elevate or lift or raise) adj3 (cassette or wafer or semiconductor) roller	JPO	AND	ON	2004/11/06 17:20
S24 0	3738	((414/222.01,217.1,222.13,626,286, 280,281,786,661,752,225,626,627, 940) or (212/312,327)).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/11/06 19:12
S24 1	59	S240 (elevate or lift or raise) adj3 (cassette or wafer or semiconductor) roller	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/06 19:13
S24 2	29	S240 (elevate or lift or raise) adj3 (cassette or wafer or semiconductor) roller conveyor	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/06 19:14
S24 6	1073	(198/346.2,468.6).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/11/06 19:13
S24 7	5	S246 (elevate or lift or raise) adj3 (cassette or wafer or semiconductor) roller	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/06 19:14
S24 8	3	S246 (elevate or lift or raise) adj3 cassette roller	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/06 19:14
S24 9	361	S246 roller conveyor	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/06 19:14
S25 0	19	S246 roller conveyor (semiconductor or wafer or cassette)	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/06 20:08
S25 5	11	S254 CONVEYOR	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/06 20:12
S25 6	11	S254 CONVEYOR ROBOT	US-PGPUB; USPAT; USOCR	AND	ON	2004/11/06 20:17
S25 7	0	CONVEYOR ROBOT ((wafer adj3 carrier) cassette) semiconductor (elevator or lift or raise)	EPO; JPO	AND	ON	2004/11/06 20:17
S25 8	0	CONVEYOR ROBOT cassette semiconductor (elevator or lift or raise)	EPO; JPO	AND	ON	2004/11/06 20:18
S25 9	35	conveyor semiconductor (elevator or lift or raise)	EPO; JPO	AND	ON	2004/11/06 20:28